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Atty. Ref.: P1339US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Hirofumi Matsuda et al.
Appl. No. : 10/780,184
Filed : February 17, 2004
For : FACSIMILE APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement includes a copy of Form PTO-1449 that identified one Japanese reference. A copy of that reference along with an English language Abstract is attached. The reference relates generally to network facsimile equipment that is intended to notify a user of a transmission result. The Examiner is requested to consider this reference during the examination and to make the reference of record.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

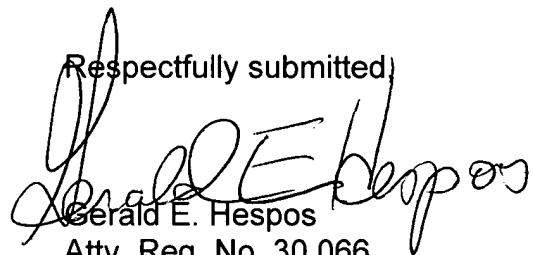
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-2450

on May 17, 2004

Marie B. Bufalo

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Respectfully submitted,


Gerald E. Hespos

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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional)

P1339US

Application Number

10/780,184

Applicant(s)

Hirofumi Matsuda et al.

Filing Date

February 17, 2004

Group Art Unit

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2001-265699	2001	Japan				✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.